

NOV 15 2004

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Jaiswal Docket No: TI-34403.1  
Serial No: 10/679,783 Examiner: McDonald, Rodney Glenn  
Filed: 10/6/2003 Art Unit: 1753  
For: CONTROL OF NICHROME RESISTOR TEMPERATURE COEFFICIENT  
USING RF PLASMA SPUTTER ETCH

*Free  
Charge*

EXTENSION OF TIME

Assistant Commissioner For Patents  
Washington, DC 20231

<p>CERTIFICATION OF FACSIMILE TRANSMISSION</p> <p>I hereby certify that the following papers are being transmitted by facsimile to the U.S. Patent and Trademark Office at 703-872-9306 on <u>11-15-04</u>.</p> <p><i>Jamie Chambers</i> Jamie Chambers</p>
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Dear Sir:

Pursuant to 37 CFR 1.136(a), Applicant(s) respectfully petition(s) the Commissioner for an extension of the shortened statutory period for response in the above identified Application.

The fee for this extension is indicated below:

<input checked="" type="checkbox"/> One Month (\$110)	<input type="checkbox"/> Three Months (\$890)
<input type="checkbox"/> Two Months (\$390)	<input type="checkbox"/> Four Months (\$1,390)

Any further necessary extension of time is hereby requested. Charge any and all fees, or credit any overpayment, to the deposit account of Texas Instruments Incorporated, Account No. 20-0668.

Respectfully submitted,

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